

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
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Atty Docket 0756-1400

Serial No. 08/520,079

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: August 28, 1995

Group Art Unit: 2815

U.S. PATENT DOCUMENTS

Examiner Initials	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
<i>CEB</i>	5,731,613	03/24/1998	Yamazaki et al.			
	5,923,968	07/13/1999	Yamazaki et al.			
	5,937,282	08/10/1999	Nakajima et al.			
	5,959,313	09/28/1999	Yamazaki et al.			
	6,093,937	07/25/2000	Yamazaki et al.			
	6,133,073	10/17/2000	Yamazaki et al.			
	6,169,292 B1	01/02/2001	Yamazaki et al.			
	6,207,969 B1	03/27/2001	Yamazaki			
	6,242,291 B1	06/05/2001	Kusumoto et al.			

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EB	5,523,257	06/04/1996	Yamazaki et al.			
	5,736,750	04/07/1998	Yamazaki et al.			
	5,891,766	04/06/1999	Yamazaki et al.			
	5,962,869	10/05/1999	Yamazaki et al.			
EB	6,114,728	09/05/2000	Yamazaki et al.			

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Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
EB	0 612 102	08/24/1994	EP			Full Eng	
	01-276615	11/07/1986	JP			Eng Abst	
	03-246973	11/05/1991	JP			Eng Abst	
	04-320346	11/11/1992	JP			Eng Abst	
	04-373171	12/25/1992	JP			Eng Abst	
	05-055140	03/05/1993	JP			Eng Abst	
	05-275699	10/22/1993	JP			Eng Abst	
	05-299339	11/12/1993	JP			Eng Abst	
EB	06-216156	08/05/1994	JP			Eng Abst	

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<i>ESB</i>	5,313,075	05/17/1994	Zhang et al.			
	5,315,132	05/24/1994	Yamazaki			
	5,572,046	11/05/1996	Takemura			
	5,648,662	07/15/1997	Zhang et al.			
	5,744,822	04/28/1998	Takayama et al.			
	5,811,328	09/22/1998	Zhang et al.			
	5,818,068	10/06/1998	Sasaki et al.			
	5,883,016	03/16/1999	Chan et al.			
<i>ESB</i>	5,985,741	11/16/1999	Yamazaki et al.			

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Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
<i>ESB</i>	05-335572	12/17/1993	JP			Eng Abst

OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
<i>ESB</i>	Inventors: Shunpei Yamazaki et al., "Thin Film Type Monolithic Semiconductor Device", Filed: December 1, 2000, Specification & Drawings of U.S. Patent Application Serial No. 09/726,336

Examiner *Paul E. Brault*Date Considered *5/2/2002*

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